

#8

Inventor: Shozo Nagano et al.

Title: Physical Vapor Deposition Targets

Assignee: Honeywell International, Inc.

Priority Serial No.: 09/449,025

Priority Filing Date: November 24, 1999

Client Ref.: 30-5000-(4015) Div. 3

**INFORMATION DISCLOSURE STATEMENT**

**PURSUANT TO 37 C.F.R. §§ 1.56, 1.97 AND 1.98**

In compliance with 37 C.F.R. §§ 1.56, 1.97 and 1.98, your attention is directed to the United States patents and other references listed on the attached Form PTO-1449. No admission is made regarding whether all the submitted references are prior art.

The listed references were cited by, or submitted to, the Office in the parent, co-pending application of the above-identified application. The above-identified application is a divisional application of co-pending application Serial No. 09/449,025, filed November 24, 1999. Such prior disclosure is sufficient for the above-identified application as far as copies of the references are concerned. 37 C.F.R. § 1.98(d) and MPEP § 609(2).

Citation of these references is respectfully requested.

Respectfully submitted,

Date: 2-13-01

Attorney: 

Mark S. Matkin  
Reg. No. 32,268  
Wells, St. John, Roberts,  
Gregory & Matkin, P.S.